

Notice of References Cited	Application/Control No. 09/874,789	Applicant(s)/Patent Under Reexamination LEYVA, RICARDO OSUNA	
	Examiner Yixing Qin	Art Unit 2622	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-5,629,775	05-1997	Platteter et al.	358/296
	C	US-			
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	J	US-			
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	L	US-			
	M	US-			

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	N	EPO 0-571-194 A1	05-1999	FR	Ueda et al	B41L 39/00
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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